

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):	HWANG, Kwang-Jo	CONF.:	5562
SERIAL NO.:	09/648,111	GROUP:	2815
FILED:	August 25, 2000	EXAMINER:	A. R. Wilson
FOR:	METHOD OF PATTERNING A METAL LAYER IN A SEMICONDUCTOR DEVICE		

AMENDMENT FILED UNDER 37 CFR §1.111

Box Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the non-final Office Action dated April 1, 2009, the following amendments and remarks are respectfully submitted in connection with the above-identified application in this Amendment.

This reply includes Amendments to the Claims and Remarks.